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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Heng-Yong Nie, et al.
Appln. No. :

International Filing Date: August 17, 2004

U.S. Filing Date:

Title : METHOD OF CONTROLLABLE MORPHOLOGY OF SELF-
ASSEMBLED MONOLAYERS ON SUBSTRATES

Grp./A.U. :
Examiner :

Docket No. :

Honorable Commissioner for Patents
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT FOR PURPOSES OF CALCULATING
FILING FEES**

Dear Sir:

Please amend the above-identified National Phase Patent Application, as follows:

Amendments to Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 12 of this paper.